

JH Rhodes Polishing Pads



M-25

www.jhrhodes.com

PRIMARY POLISHING PAD - UNFILLED

The M-25 is an unfilled, small pore size polyurethane pad. (Modified version of LP-57)
It is designed for reduced defects during silicon wafer primary polishing.

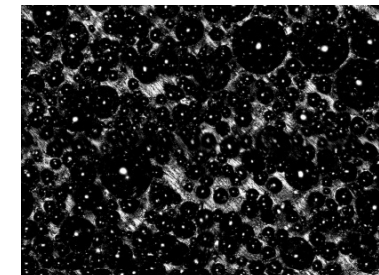
BENEFITS

- ✓ High stock removal rate
- ✓ Low pad wear
- ✓ Low defect level

TYPICAL APPLICATIONS

Sapphire, Silicon

M-25 PAD PROPERTIES (Average)				
FILLER	DENSITY [g/cm ³ (lb/ft ³)]	HARDNESS (Shore A)	COMPRESSIBILITY (%)	ELASTIC REBOUND (%)
None	0.42 (26.0)	89	7.5	90



Values are subject to change without notification.